



Docket No. 205235US0PCT

IN RE APPLICATION OF: Yasutaka ITO, et al.

SERIAL NO: 09/831,887

FILED: May 23, 2001

FOR: CERAMIC HEATER

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

RECEIVED

FEB 13 2003

TECHNOLOGY CENTER R3700

SIR:

Transmitted herewith is an amendment in the above-identified application.

- No additional fee is required
- Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- Additional documents filed herewith: Request for Extension of Time (3 Months), Marked-Up Copy, Attachments (Fig. A and Fig. B)

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	24	MINUS	12	12	x \$18 =	\$216.00
INDEPENDENT	4	MINUS	4	0	x \$84 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$280 =	\$0.00
						TOTAL OF ABOVE CALCULATIONS
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$216.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
						TOTAL
						\$216.00

- A check in the amount of \$1,146.00 is attached.
- Please charge any additional Fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Norman F. Oblon

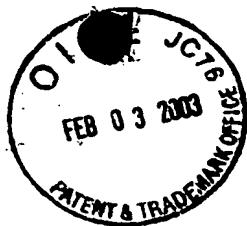
Registration No. 24,618

Masayasu Mori

Registration No. 47,301

Customer Number 22850
Tel. (703) 413-3000
Fax. (703) 413-2220
(OSMMN 10/01)
NFO/MM/rtr
I:\USER\MSMOR\205235.CV.DOC

205235US-0PCT



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF : *[Signature]*
2-27-03

Yasutaka ITO, et al. : EXAMINER: FASTOVSKY, L

SERIAL NO: 09/831,887 : *[Signature]*

FILED: MAY 23, 2001 : GROUP ART UNIT: 3742

FOR: CERAMIC HEATER

RECEIVED

AMENDMENT

FEB 13 2003
TECHNOLOGY CENTER R3700

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

In response to the Office Action dated August 2, 2002, please amend the above-identified application as follows:

IN THE CLAIMS

A clean copy of the claims incorporating any amendment is shown below.

Please add new Claims 13-28 as follows:

13. (New) The ceramic heater according to Claim 1, wherein a semiconductor wafer is heated while being held by a supporting pin at a distance of 1 to 5000 μm apart from the work-heating surface of the ceramic heater.

14. (New) The ceramic heater according to Claim 2, wherein a semiconductor wafer is heated while being held by a supporting pin at a distance of 1 to 5000 μm apart from the work-heating surface of the ceramic heater.

02/04/2003 SDENB0B1 00000088 09831887
01 FC:1202 216.00 OP